

APPLICATION NO.

10/711,473

UNITED STATES PATENT AND TRADEMARK OFFICE

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09/21/2004 Hsi-Ming Chang 13530-US-PA 5472

02/25/2005 EXAMINER

NTELLECTUAL PROPERTY OFFICE ERDEM, FAZLI

JIANQ CHYUN INTELLECTUAL PROPERTY OFFICE 7 FLOOR-1, NO. 100
ROOSEVELT ROAD, SECTION 2
TAIPEI, 100
TAIWAN

2826
DATE MAILED: 02/25/2005

ART UNIT

Please find below and/or attached an Office communication concerning this application or proceeding.

- ;		Application No.	Applicant(s)
Office Action Summary		10/711,473	CHANG, HSI-MING
		Examiner	Art Unit
		Fazli Erdem	2826
The MAILING DATE of this communication appears on the cover sheet with the correspondence address Period for Reply			
A SHORTENED STATUTORY PERIOD FOR REPLY IS SET TO EXPIRE 3 MONTH(S) FROM THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.136(a). In no event, however, may a reply be timely filed after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply within the statutory minimum of thirty (30) days will be considered timely. - If NO period for reply is specified above, the maximum statutory period will apply and will expire SIX (6) MONTHS from the mailing date of this communication. - Failure to reply within the set or extended period for reply will, by statute, cause the application to become ABANDONED (35 U.S.C. § 133). Any reply received by the Office later than three months after the mailing date of this communication, even if timely filed, may reduce any earned patent term adjustment. See 37 CFR 1.704(b).			
Status			
1)[🛛) Responsive to communication(s) filed on 21 September 2004.		
2a)□	• • • • • • • • • • • • • • • • • • • •	s action is non-final.	
3)□	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.		
Disposition of Claims			
4)🖂	☑ Claim(s) <u>1-18</u> is/are pending in the application.		
	4a) Of the above claim(s) is/are withdrawn from consideration.		
5)□	D Claim(s) is/are allowed. D Claim(s) <u>1,2,6,12 and 18</u> is/are rejected. D Claim(s) <u>1-3,5-8,10-13 and 15-17</u> is/are objected to.		
6)⊠			
·			
8) Claim(s) are subject to restriction and/or election requirement.			
Application Papers			
9) The specification is objected to by the Examiner.			
10)[0)☐ The drawing(s) filed on is/are: a)☐ accepted or b)☐ objected to by the Examiner.		
	Applicant may not request that any objection to the drawing(s) be held in abeyance. See 37 CFR 1.85(a).		
	Replacement drawing sheet(s) including the correction is required if the drawing(s) is objected to. See 37 CFR 1.121(d).		
11)☐ The oath or declaration is objected to by the Examiner. Note the attached Office Action or form PTO-152.			
Priority under 35 U.S.C. § 119			
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No. 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). 			
* See the attached detailed Office action for a list of the certified copies not received.			
Attachment(s)			
1) X Notic 2) Notic	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-948)	4)	
3) 🔲 Inforr	e of Draitsperson's Patent Drawing Review (PTO-948) mation Disclosure Statement(s) (PTO-1449 or PTO/SB/08) r No(s)/Mail Date		atent Application (PTO-152)

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DETAILED ACTION

Allowable Subject Matter

1. Claims 3-5, 7-11 and 13-17 objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1, 2, 6, 12 and 18 rejected under 35 U.S.C. 103(a) as being unpatentable over Shih (2003/0230748) in view of Song et al. (5,990,986) further in view of Peng et al. (2004/0219723).

Regarding Claims 1, 2, 6, 12 and 18, Shi discloses manufacture of TFT planer display panel and process for manufacturing the same where in 3A-3G, it is disclosed a substrate 300, polysilicon layer 304, lighly doped drain regions 309, gate insulating layer 307, gate buffer layer, dielectric layer 310 arranged over gate insulating film 307, source and drain regions 306. Shi fails to disclose the gate buffer layer over the gate insulating layer and the required source/drain metal layers. However, Song et al. disclose a thin film transistor substrate for a liquid crystal display having buffer layers and a manufacturing method thereof where in Fig. 3, buffer layers 51 and 52 are located over the gate insulating film which is labeled 20. Furthermore, Peng et al. disclose a low

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temperature polysilicon thin film transistor and method of manufacturing the same where in Figs. 1I and 1J source and drain metal configuration are disclosed as 146

It would have been obvious to one of having ordinary skill in the art at the time the invention was made to include the required gate buffer configuration and the required source and drain metal configuration in Shih as taught by Song et al. and Peng et al. respectively in order to have low temperature polysilicon thin film transistor with increased performance.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Fazli Erdem whose telephone number is (571) 272-1914. The examiner can normally be reached on M - F 8:00 - 5:00.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nathan Flynn can be reached on (571) 272-1915. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

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FE

February 21, 2005

NATHAN J. FIXIN SUPERVISORY PATENT EXAMINER ECHNOLOGY CENTER 2800